

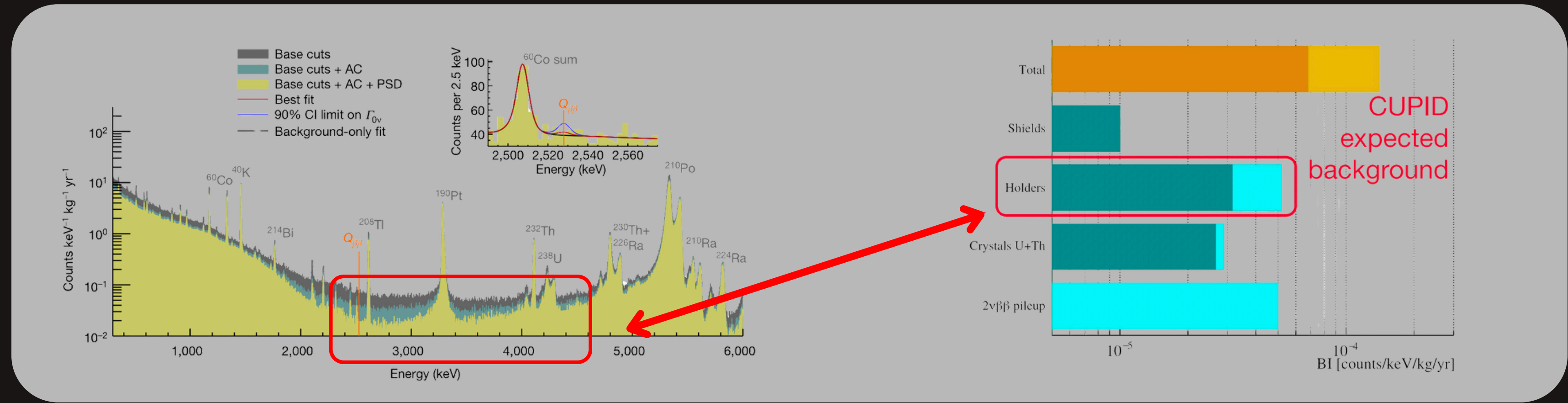
# SURFaCE: a cryogenic $\alpha$ detector for the radioactive contamination of material surfaces

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# SURFACE $\alpha$ 's AS A BACKGROUND

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## $0\nu\beta\beta$ BOLOMETRIC SEARCHES

- Bolometric experiments (e.g., CUORE) face high background from degraded  $\alpha$  particles in support materials (mainly copper).
- Next-gen experiments (CUPID, AMORE) will use scintillating crystals for better particle ID.
- Surface  $\beta$ 's (e.g.,  $^{214}\text{Bi}$ ) remain a significant background source.

## WIMP SEARCHES

- Searches with scintillating crystals are sensitive to surface contamination of the reflector.
- Searches with bolometers face  $\beta$  and nuclear recoil background from surface contamination.
- Searches with TPCs are affected by  $^{222}\text{Rn}$  diffusion; Rn outgassing can be measured for some materials only.

# REQUIREMENTS FOR NEXT-GENERATION $\alpha$ DETECTOR

- Sensitivity to surface  $^{232}\text{Th}$  or  $^{238}\text{U}$  contamination down to a few nBq/cm<sup>2</sup>
  - **Area**  $\geq 1 \text{ m}^2$
  - **Background**  $\leq 10^{-8}$  counts/s/cm<sup>2</sup> in the full  $\alpha$  range
- Capability to distinguish different parts of the  $^{232}\text{Th}$  and  $^{238}\text{U}$  chain that are out of equilibrium
  - **Energy resolution**  $\leq 20 \text{ keV FWHM}$  to distinguish different  $\alpha$  peaks
- Sensitivity to depth profile of surface contamination
  - No deformation induced by e.g. **dead layers**
  - **Energy resolution** of few keV FWHM

**NONE OF THE EXISTING TECHNOLOGIES SATISFY ALL THESE REQUIREMENTS!**

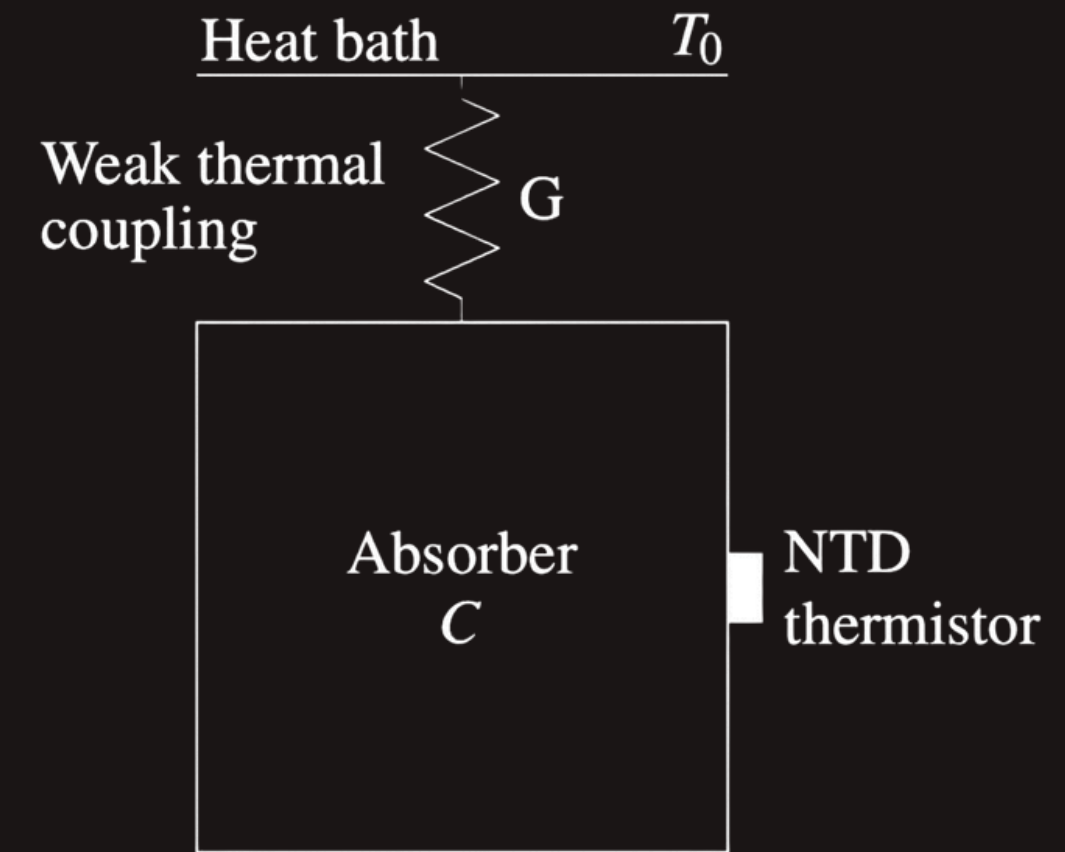
Name	Producer or location	Background level [10 <sup>-9</sup> cts/s/cm <sup>2</sup> ]	Background region [MeV]	FWHM @5 MeV [keV]	Active area [m <sup>2</sup> ]	Sensitivity [nBq/cm <sup>2</sup> ]
UltraLo-1800	XIA	~250	2.5-10	~400	0.18	~30
PIPS	various	~10 <sup>4</sup>	1-10	$\geq 20$	0.0012	~10 <sup>4</sup>
Bi-Po	LSC	0.1			3.6	~0.1
TPCs	various	1-30	2.5-10	150-300	$\leq 0.24$	1-30

# CRYOGENIC CALORIMETERS

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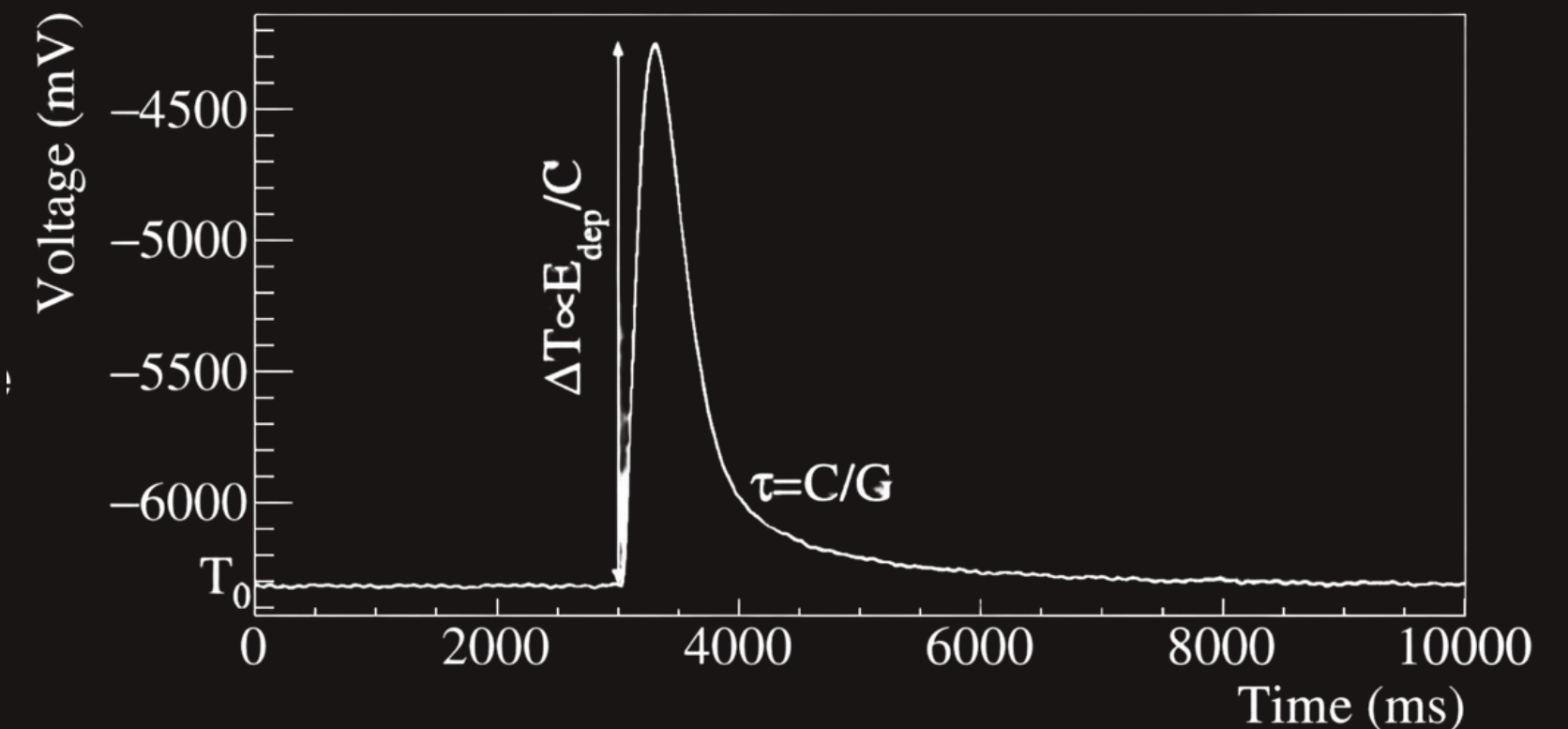
Highly sensitive calorimeter operated at cryogenic temperature ( $\sim 10$  mK).  
Energy measured as temperature variation of the absorber:

$$\Delta T(t) = \frac{\Delta E}{C} \exp\left(-\frac{t}{\tau}\right) \quad \tau = C/G$$



## MAIN ADVANTAGES

- Detector **modularity**
- Stable **long-term** operation possible
- Great dynamic range, **few keV to 10 MeV**
- Excellent **energy resolution** ( $\leq 10$  keV FWHM)
- Possibility to use **different absorber crystals** and select the one with the lowest radioactive contamination



# THE DETECTOR CONCEPT

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## DETECTOR STRUCTURE

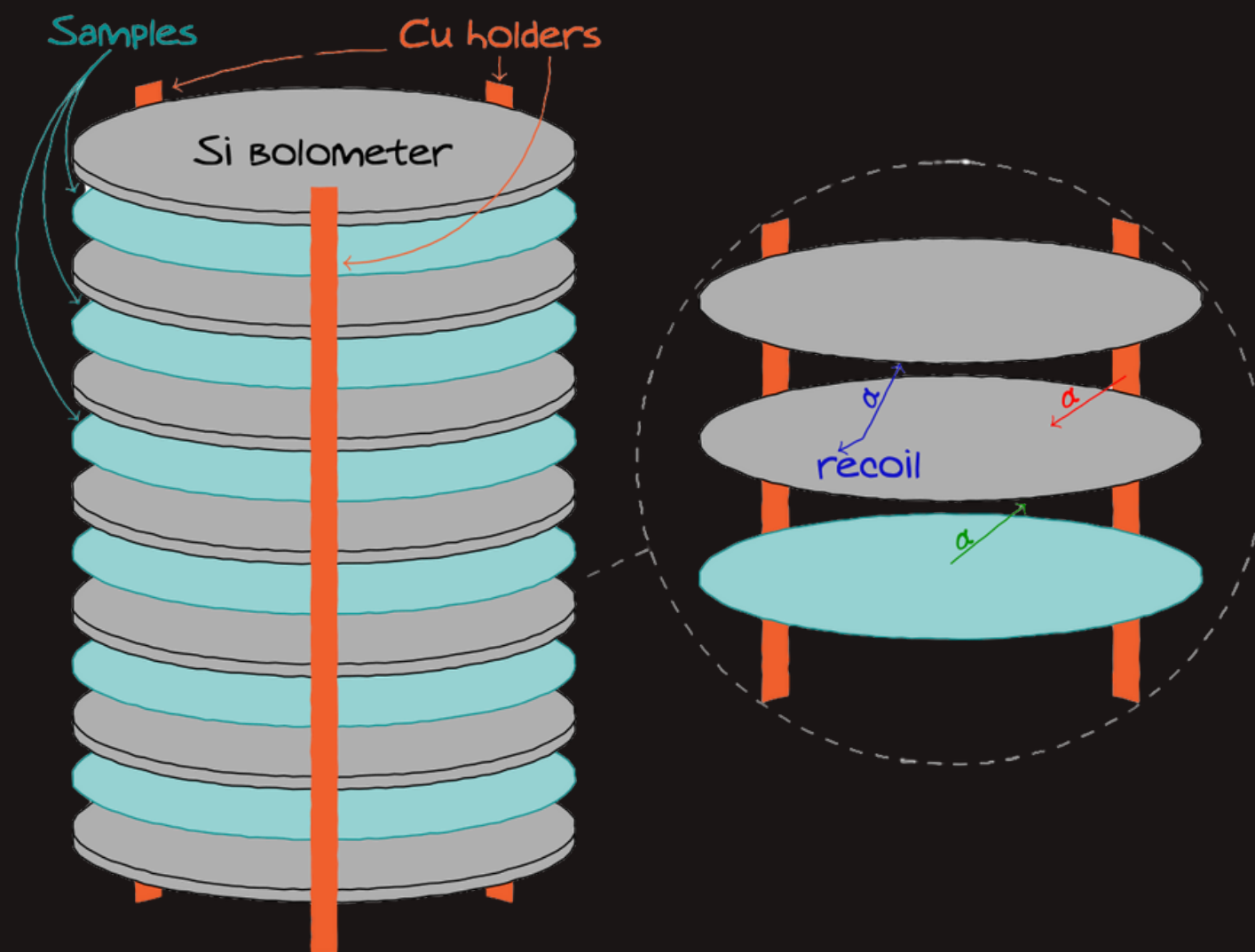
- Large-area crystal wafer as an energy absorber.
- Mounted on a minimally-sized frame.
- Readout by a Neutron Transmutation Doped (NTD) thermistor glued on it.

## MATERIAL CHOICE

- Silicon is selected for its purity and accessibility.
- High-resistivity intrinsic float-zone silicon is preferred.
- Resistivity  $\geq 10 \text{ k}\Omega\cdot\text{cm}$  for low heat capacity.
- Wafer size: 15 cm (29 modules for  $1 \text{ m}^2$ )

## DETECTOR HOLDER DESIGN

- Area facing wafer:  $\sim 20 \text{ cm}^2$  (1/10 of wafer's side).
- Frame is suitable for mounting one tower in a 40-50 cm diameter cryostat.
- Features for easy mounting, dismounting, and sample exchange.





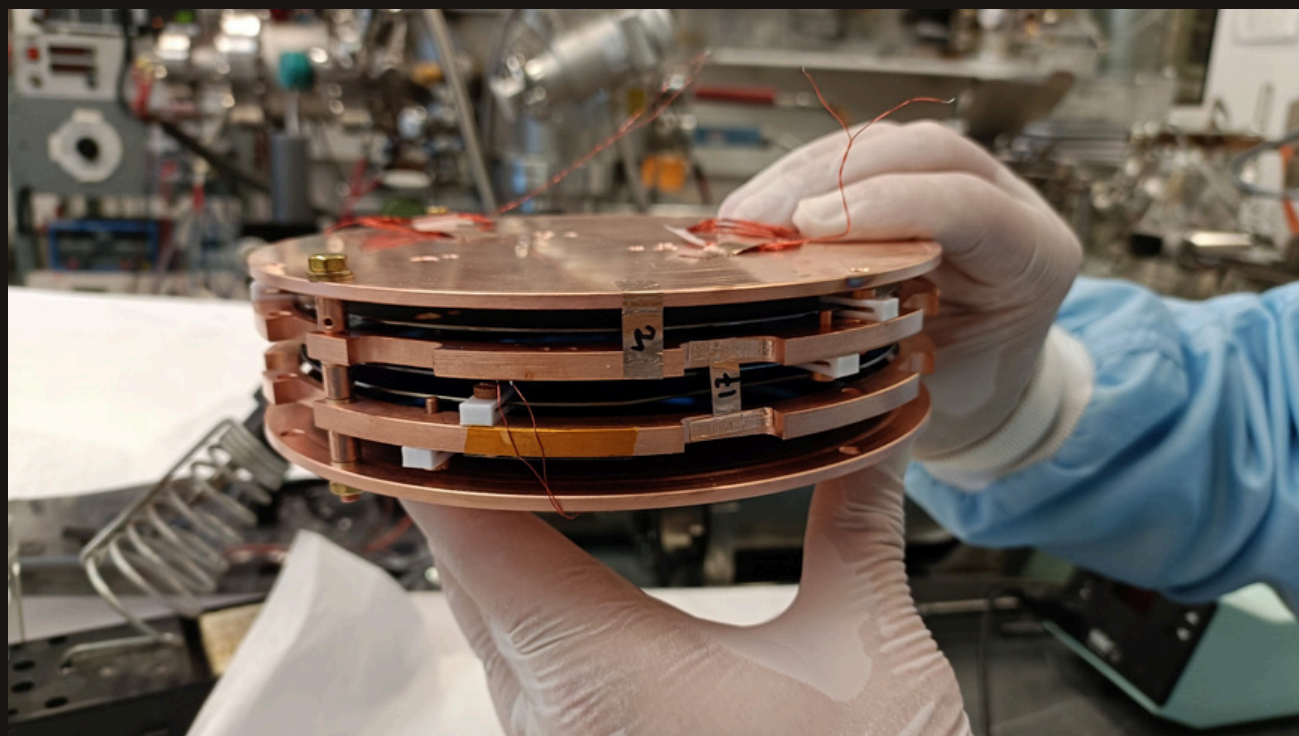
# THE DETECTOR PROTOTYPE

## PROTOTYPE CONSTRUCTION

- 4 silicon wafers
- **Diameter:** 15 cm
- **Thickness:** 1 mm
- Mounted on 2 copper frames (2 wafers/frame)

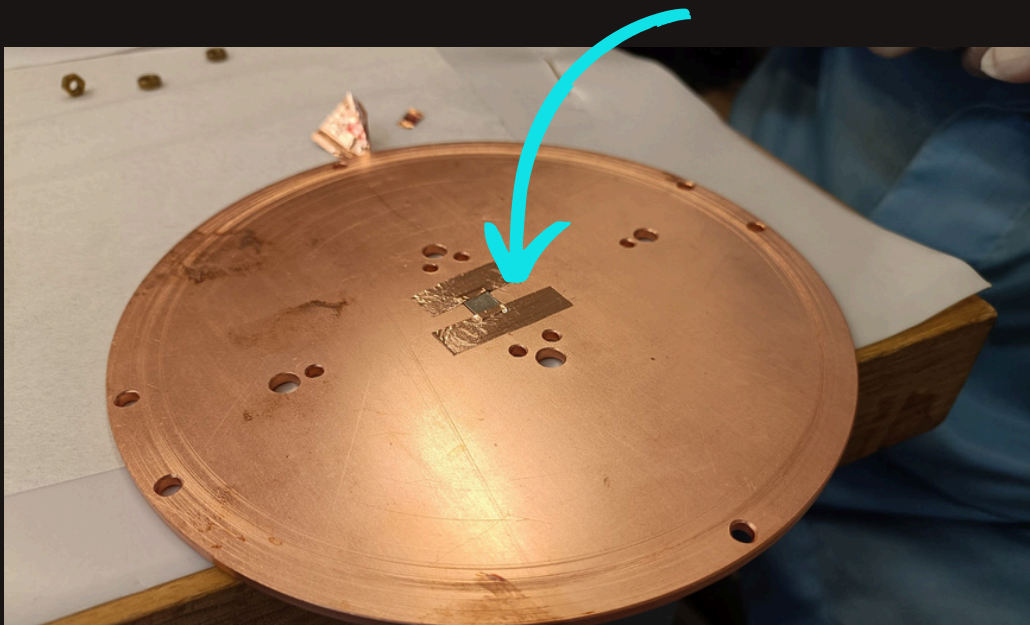
## TESTING

- Several runs between February 2023 and April 2024
- Location: installed in the **CROSS** cryostat at Canfranc



## DATA

- **Runs:**
  - 1-hour run with **LED pulses**, January
  - 7-days run for **alpha measurements**, January
  - 3-days **background** run with 3 detectors, March
- **Detectors:**
  - A wafer w/o alpha sources (ch 80, 81)
  - A wafer with an alpha source  $^{210}\text{Po}$  (ch 82)



Run	Channels	Acquired data
January	80	LED
	82	$^{210}\text{Po}$ , LED
March	80, 81, 82	Background

# LED CALIBRATION SYSTEM

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## SYSTEM DESIGN

- Utilizes a light source (**LED or laser**) at room temperature
- Light is distributed to detectors via **optical fibers**

## CALIBRATION METHOD

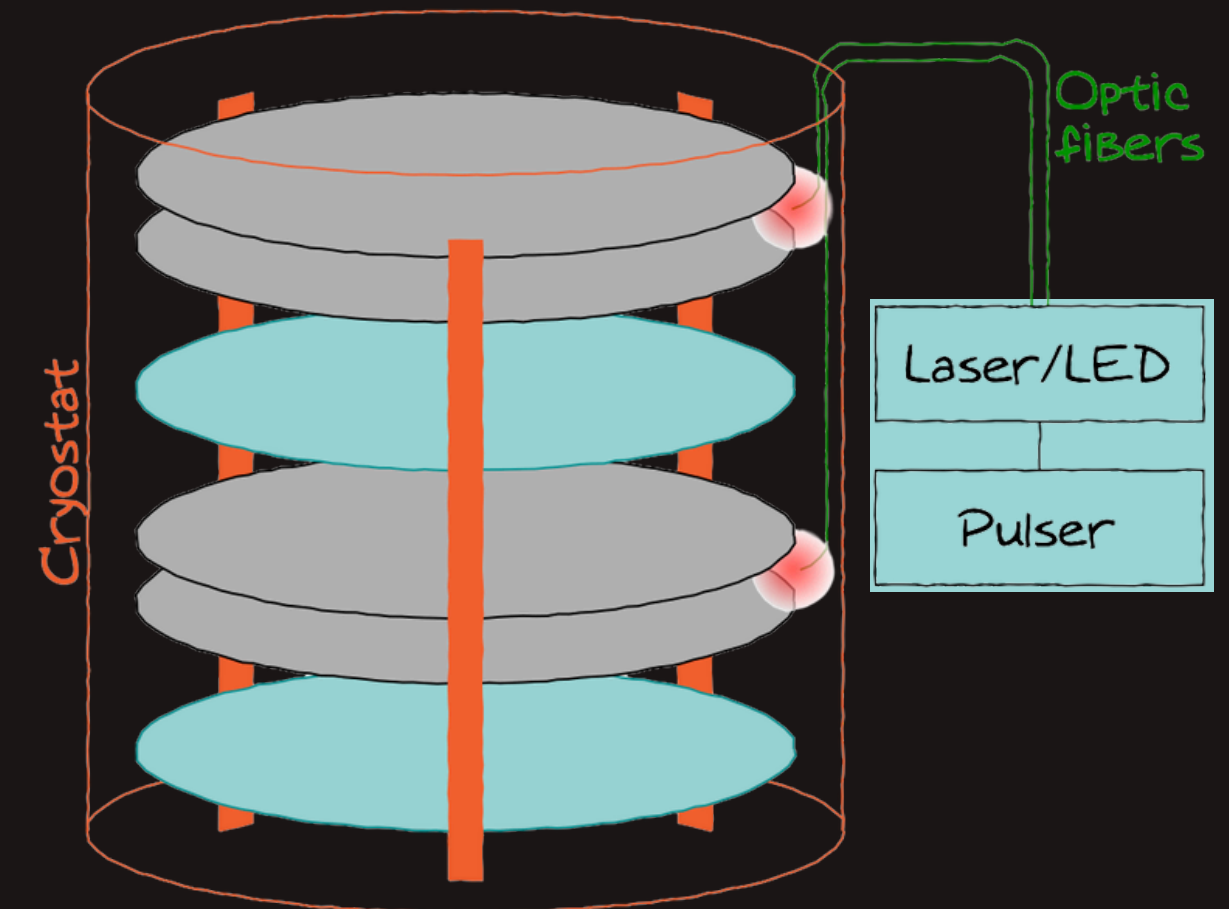
- Injects light pulses with varying amplitudes to linearize the detector response
- **Energy calibration:** the Poisson statistics of the light

## CURRENT ACHIEVEMENT AND GOALS

- Technique proven effective from **~100 eV to 10 keV**
- Aim to extend this method **up to 10 MeV**

## ADVANTAGES

- Simplifies the operation of the detectors
- Could potentially replace heater-based stabilization

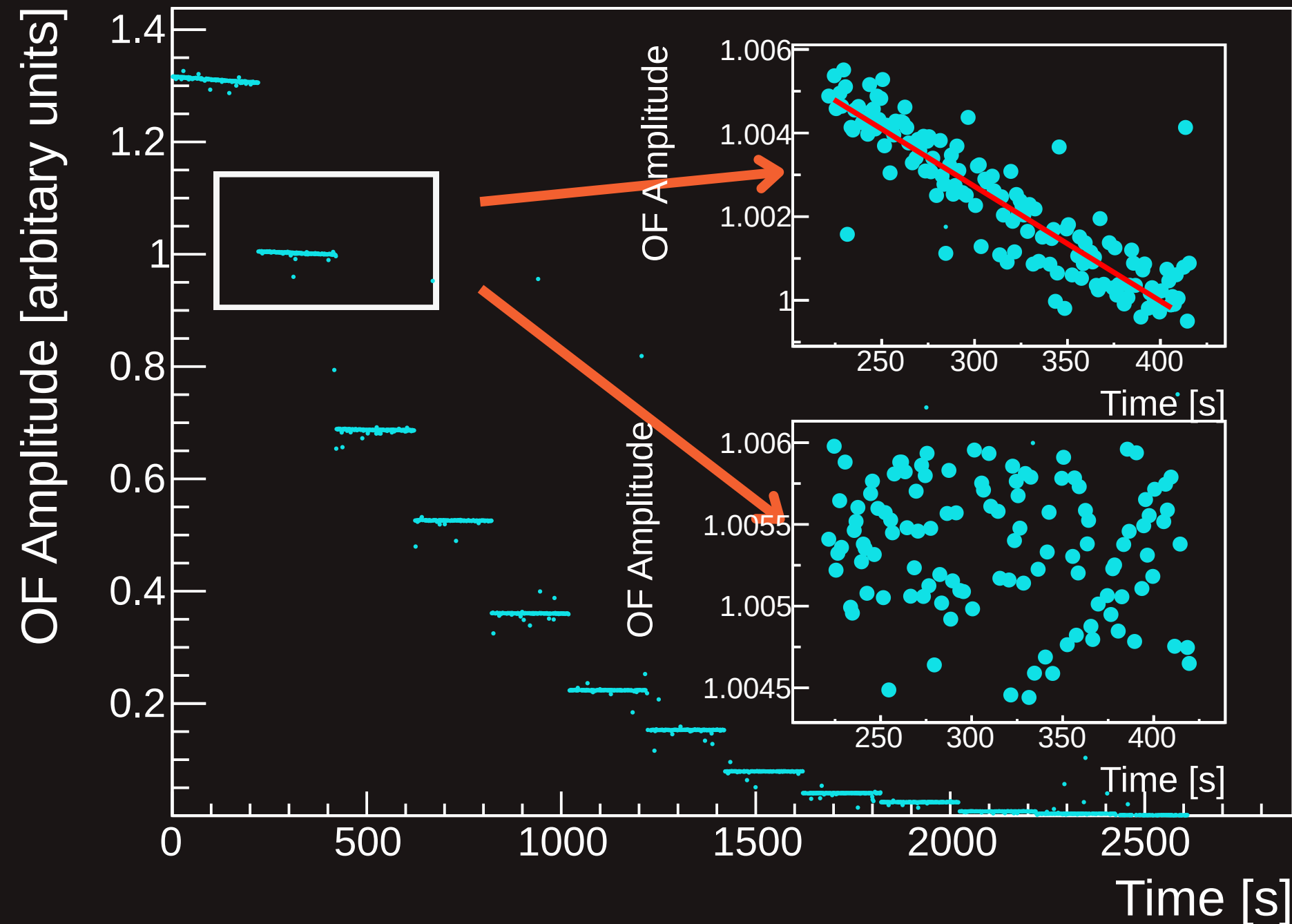


# LED RUN DATA PROCESSING

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Ch 82, January

**before stabilization**



**after**

## A RUN WITH LED PULSES

- **13** amplitudes
- ~**200** pulses per amplitude
- **Amplitude Variation:** Pulse widths change according to a set pattern
- **Pulse Width Pattern:**  
200, 150, 100, 75, 50, 30, 20, 10, 5, 3, 1, 0.5, 0.2  $\mu$ s



# LED RUN DATA PROCESSING

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AP  
ANPS

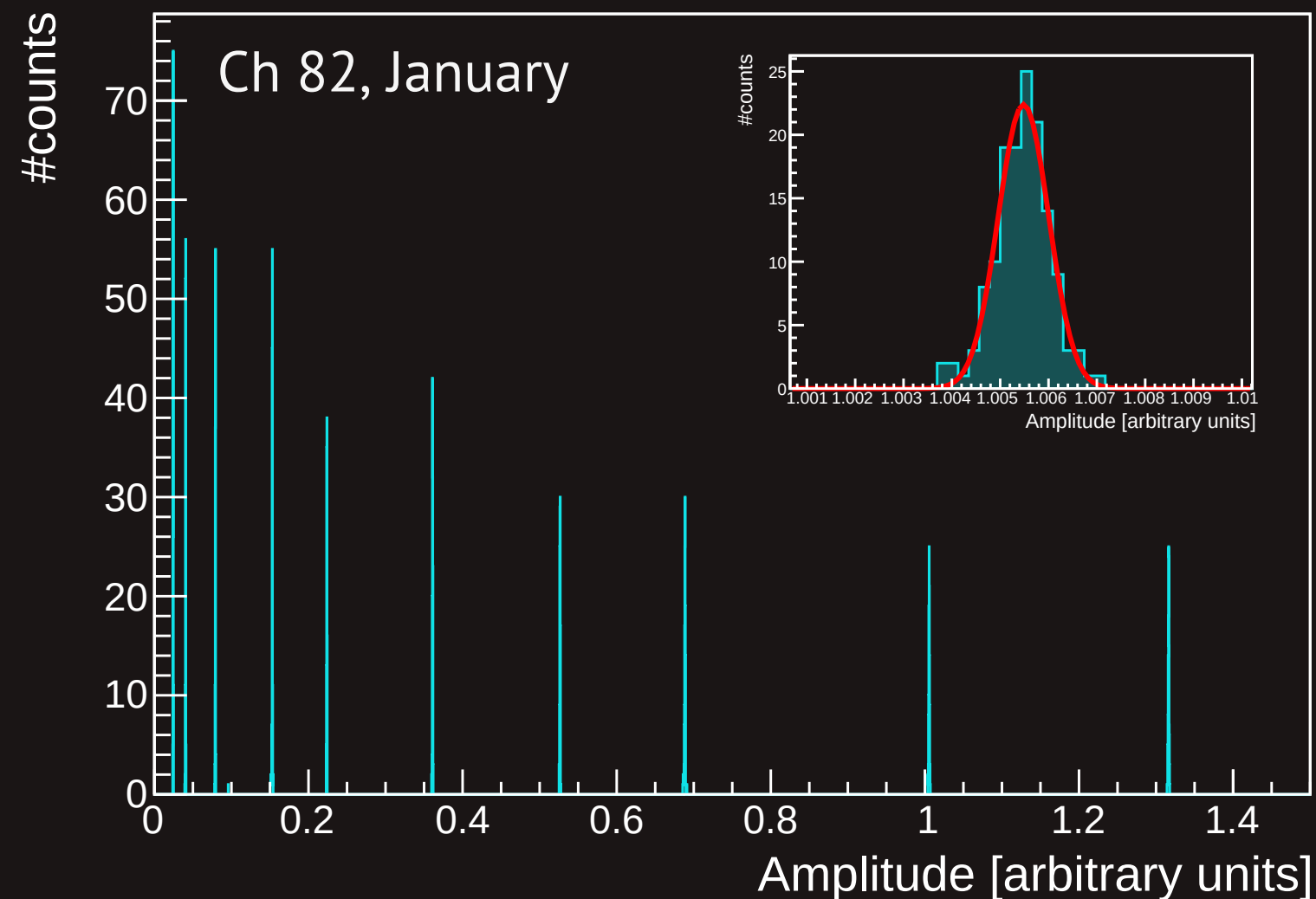
Optimum Filter

Pulser Finder

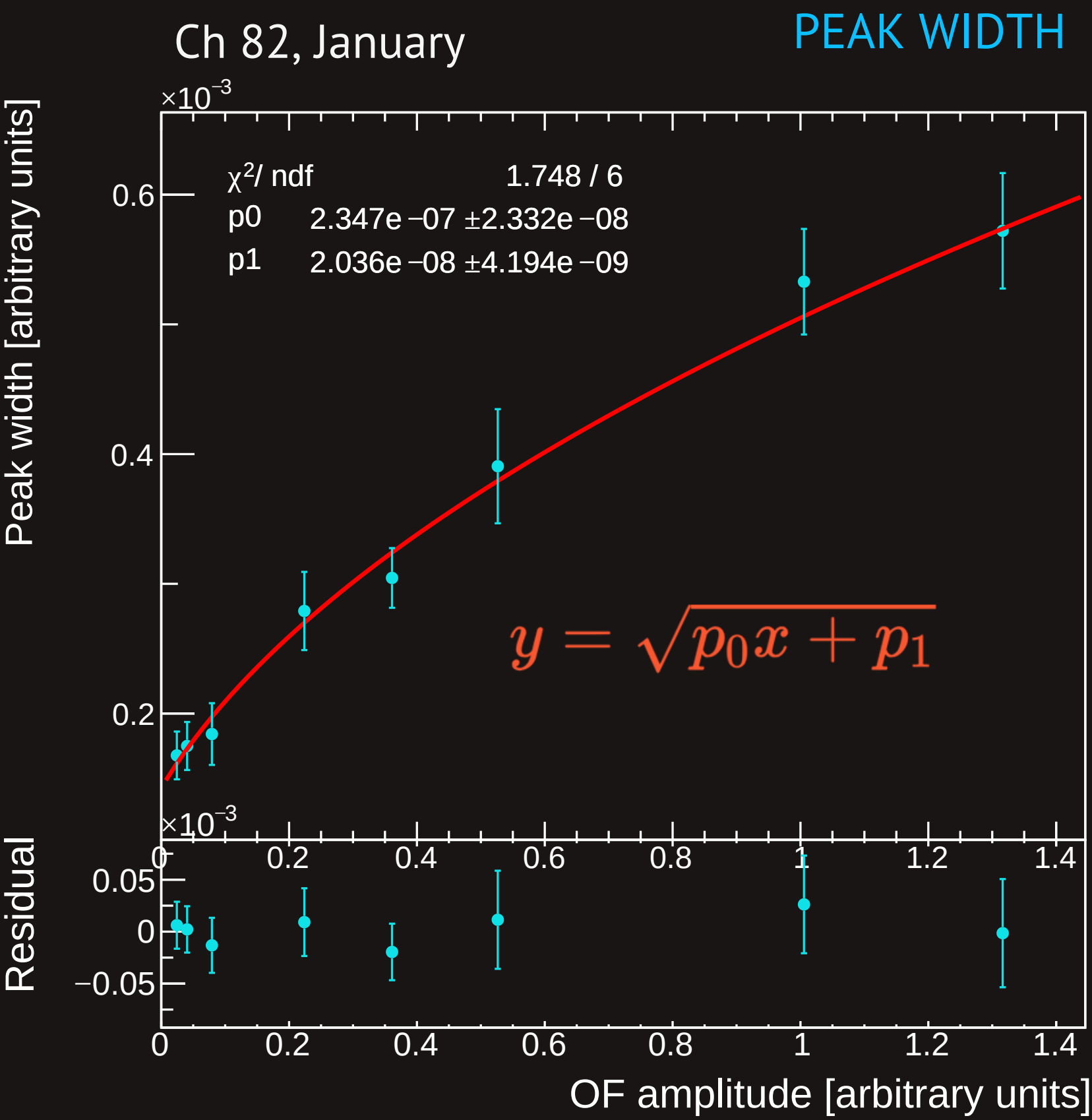
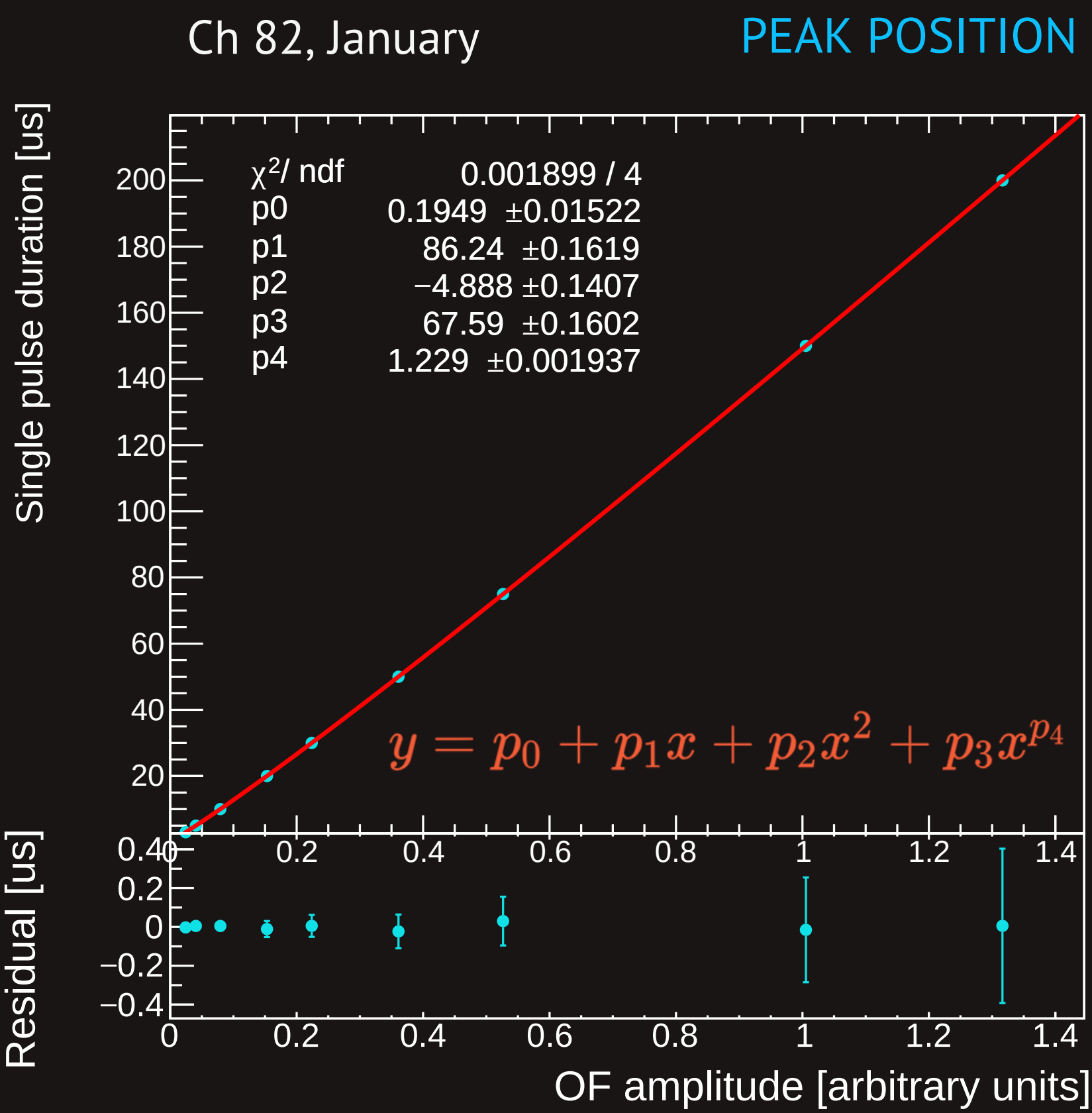
Stabilization in time

**Self-calibration**

based on the Poisson  
statistics of the light



# RESIDUALS



# SELF-CALIBRATION PRINCIPLE

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Ch 82, January

$$A_{OF} = R \cdot E_{keV} = R \cdot N_{\gamma} E_{\gamma}$$

Number of photons

Single photon energy

$$\sigma_{kev} = E_{\gamma} \sqrt{N_{\gamma} + b}$$

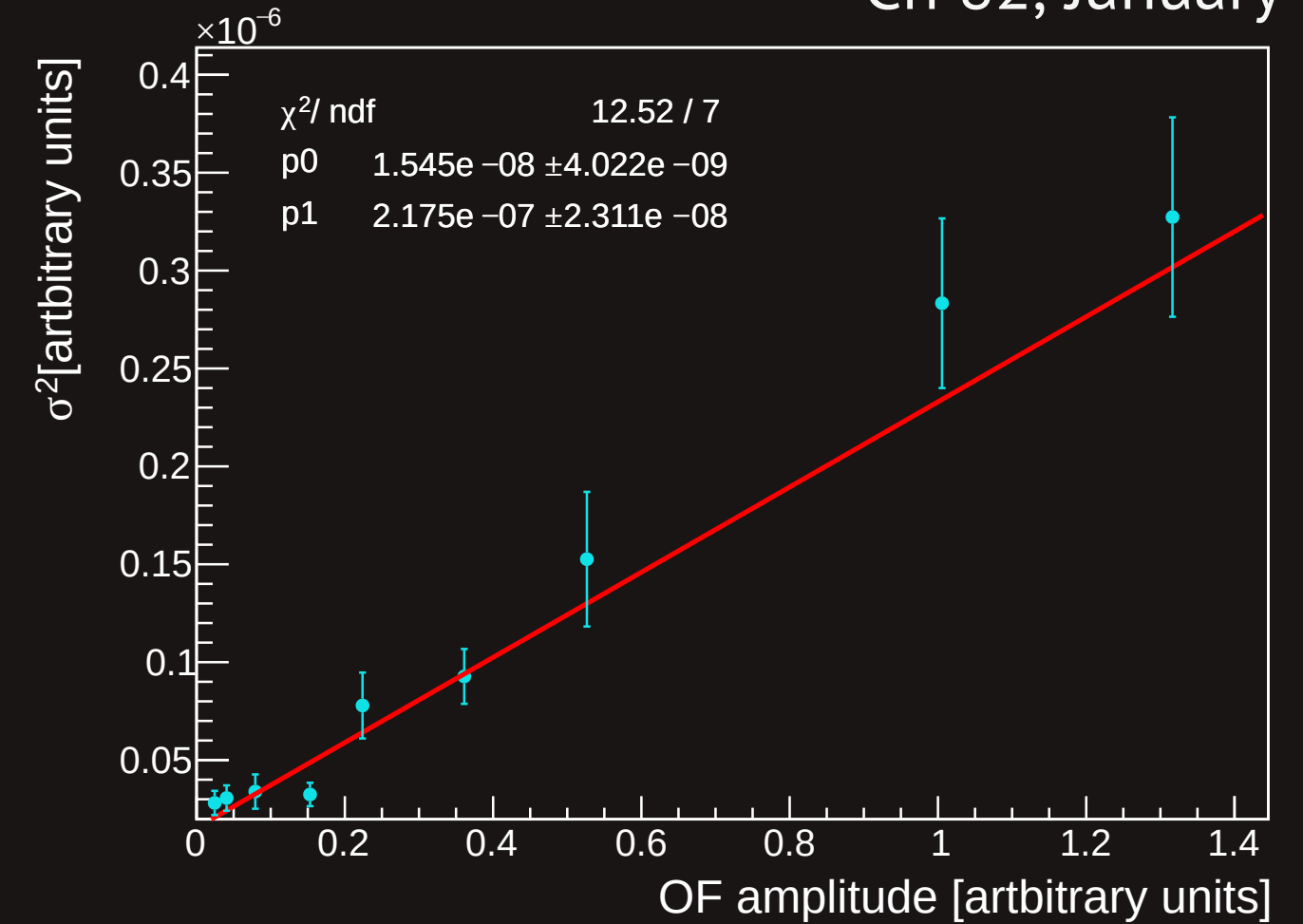
Poissonian term

Baseline resolution

$$\sigma_{OF}^2 = R^2 \sigma_{kev}^2 = B^2 + R^2 N_{\gamma} E_{\gamma}^2 = B^2 + A_{OF} E_{\gamma} R$$

→

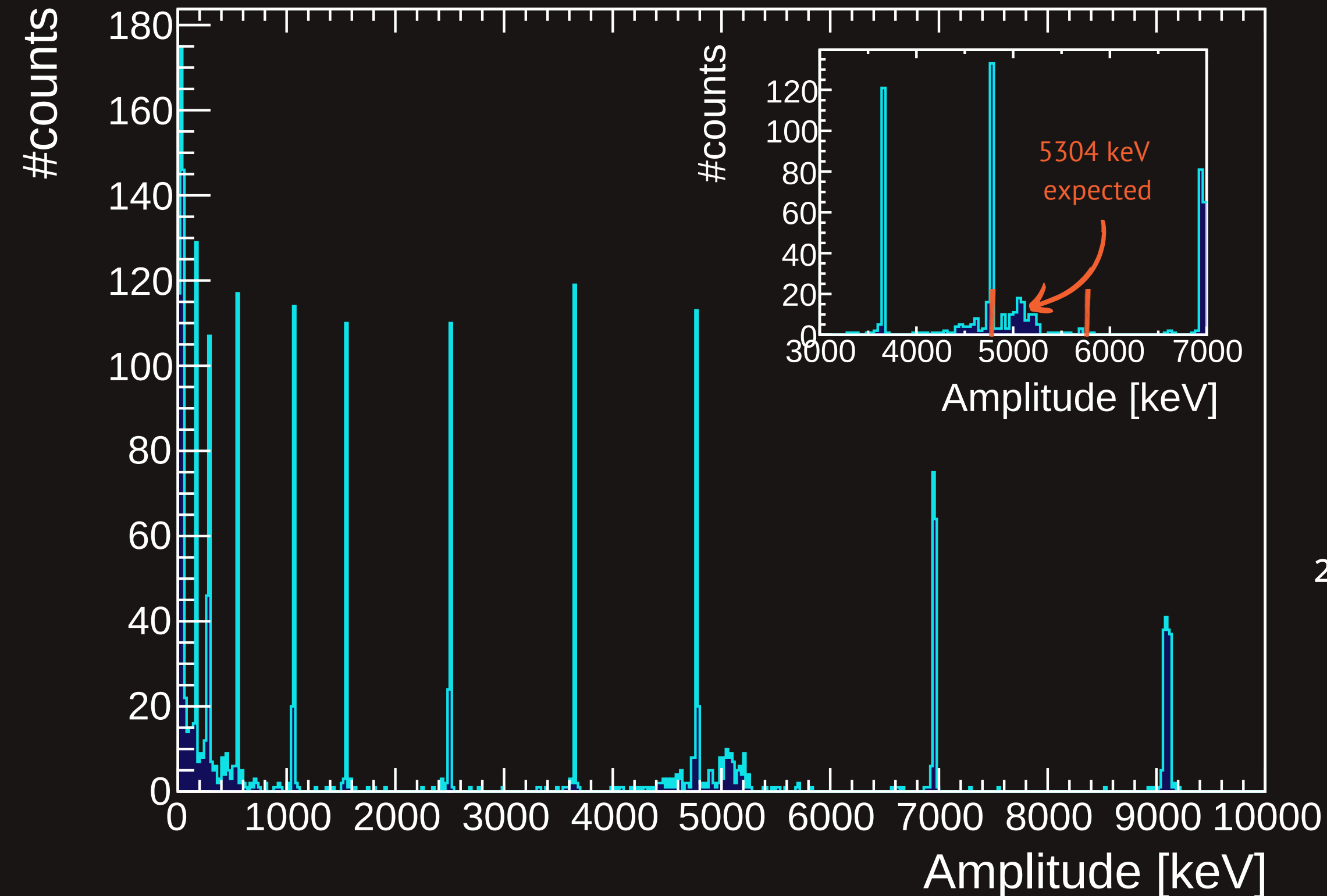
$$A_{kev} = \frac{A_{OF}}{R}$$



# SELF-CALIBRATION RESULTS

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Ch 82, January



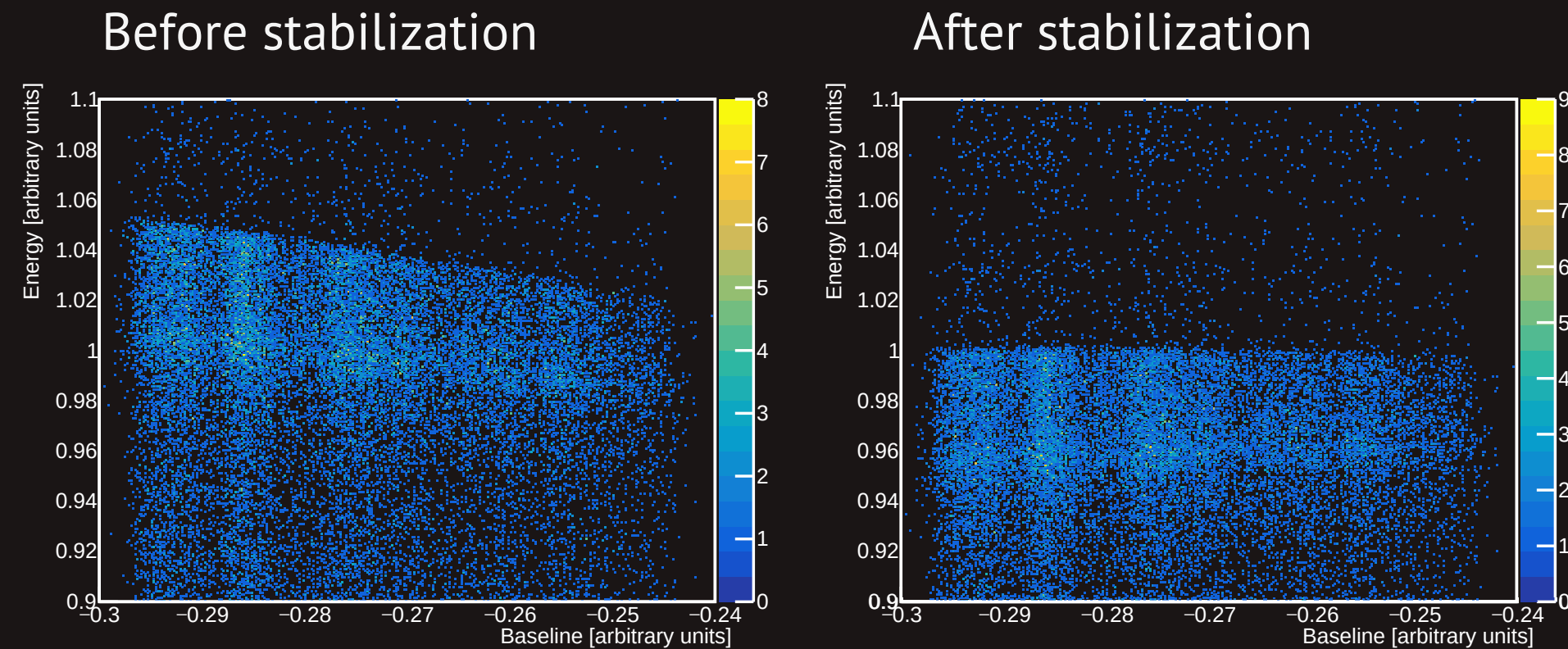
$$E_{\gamma} = 1.51 \text{ eV } (\lambda = 820 \text{ nm})$$

$$R = 1.44 \times 10^{-4} \pm 1.5 \times 10^{-5}$$

$^{210}\text{Po}$  peak is inside expected region  
self-calibration works!

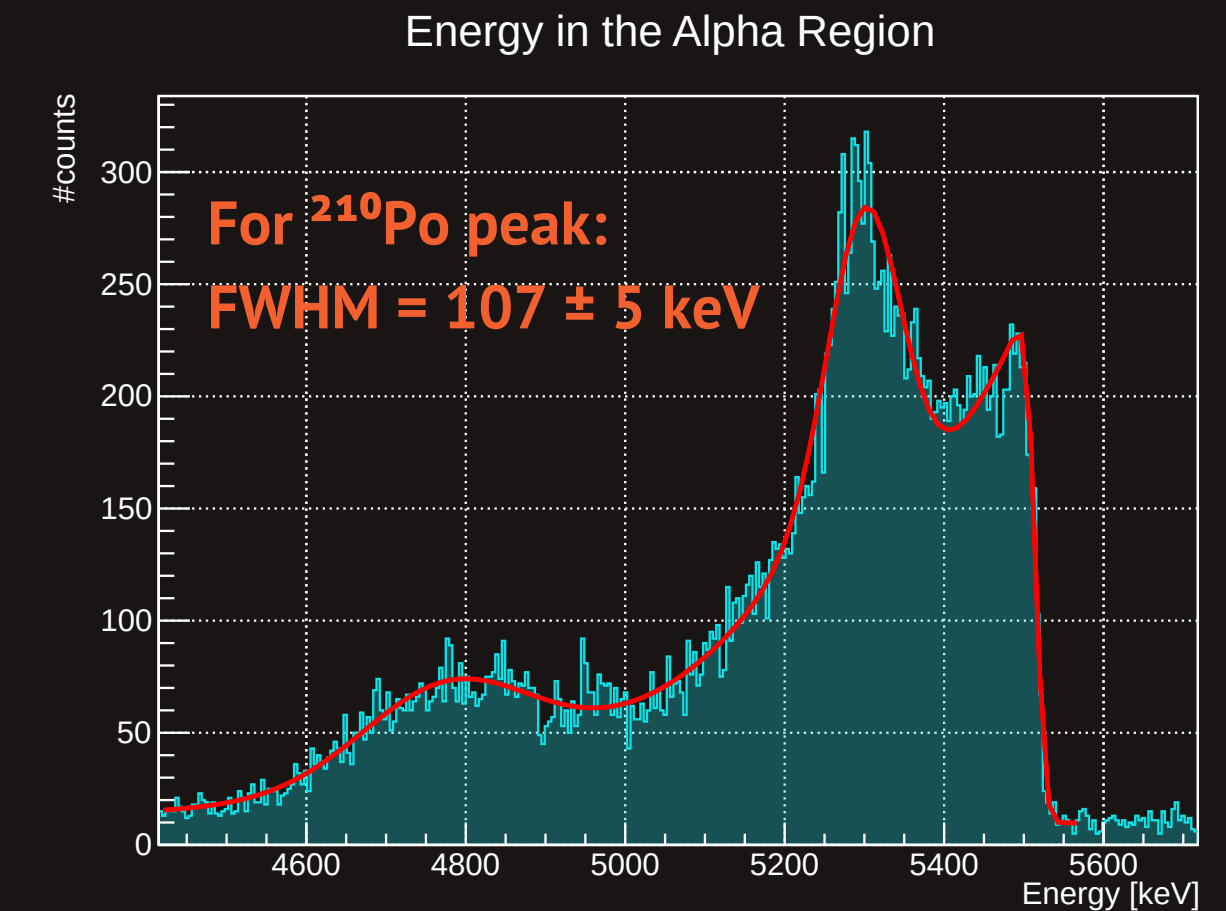
# MEASUREMENT WITH $\alpha$ SOURCE

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Ch 82, January

TEMPERATURE DRIFT CORRECTION



Ch 82, January

FIT FUNCTION

Low-energy tail

$$f(E) = A \exp\left(-\frac{(E - \mu)^2}{2\sigma^2}\right) + B + C \exp\left(\frac{E - \mu}{\delta}\right) \operatorname{erfc}\left(\frac{E - \mu}{\sqrt{2}\sigma} + \frac{\sigma}{\sqrt{2}\delta}\right)$$

Gaussian

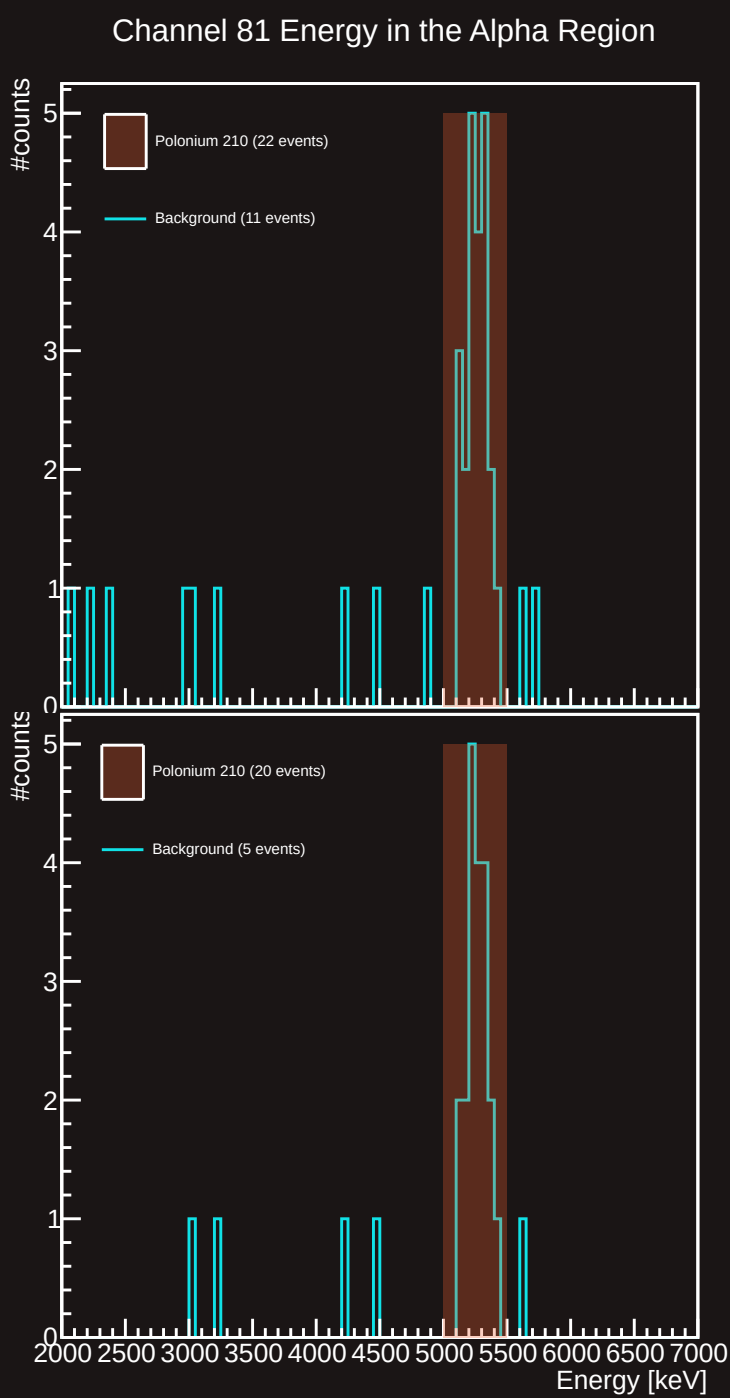
Flat background



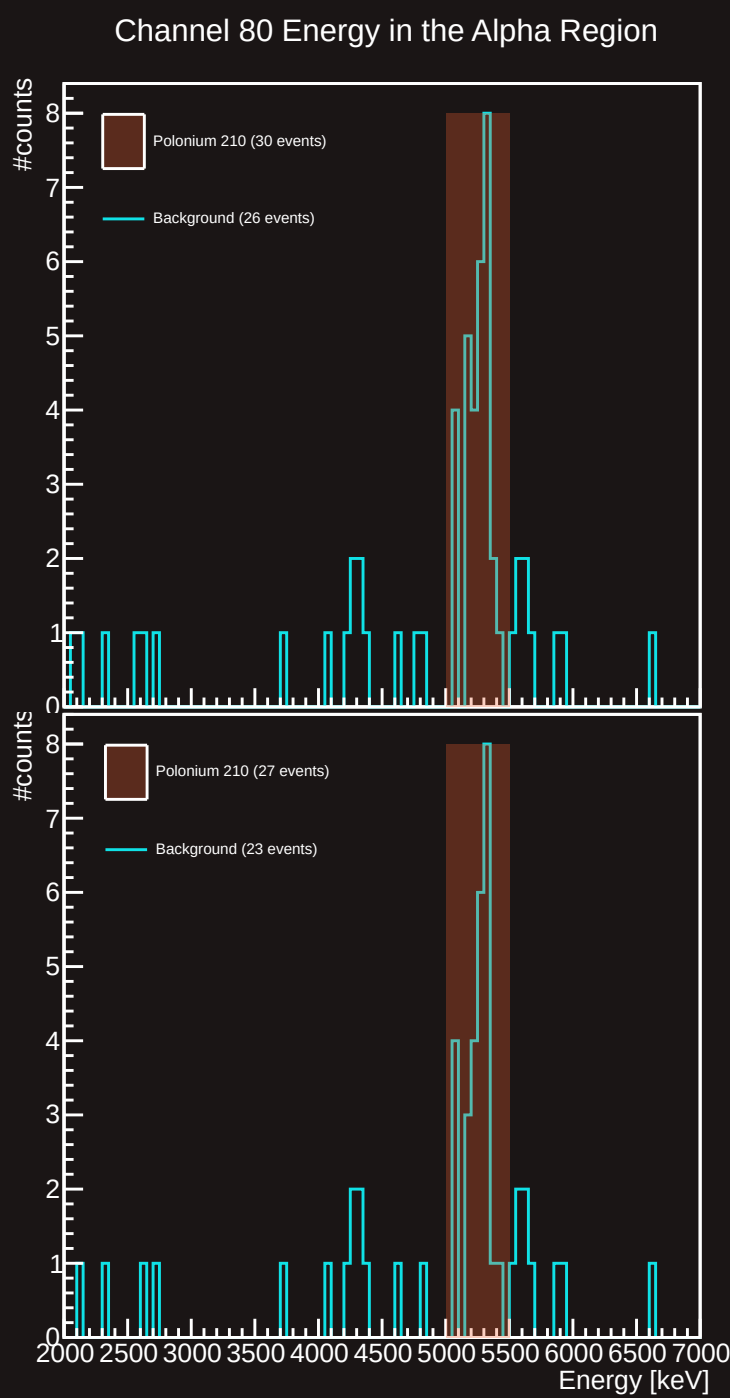
# HIGH-ENERGY BACKGROUND

ALL EVENTS

M1 EVENTS



Ch 81, March



Ch 80, March

Number of events in ROI

$$B = \frac{N_e}{2 \cdot \pi R^2 \cdot \Delta t}$$

Radius of the wafer (7.5 cm<sup>2</sup>)

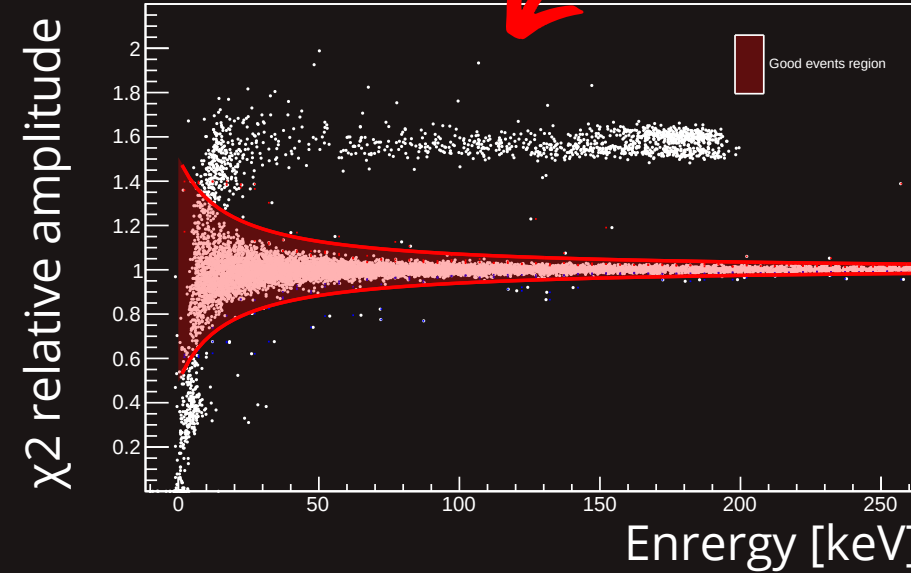
Run time

Channel	Total background [events/cm <sup>2</sup> /s]	M1 background [events/cm <sup>2</sup> /s]
80	(32 ± 6) · 10 <sup>-8</sup>	(28 ± 6) · 10 <sup>-8</sup>
81	(13 ± 4) · 10 <sup>-8</sup>	(6 ± 3) · 10 <sup>-8</sup>

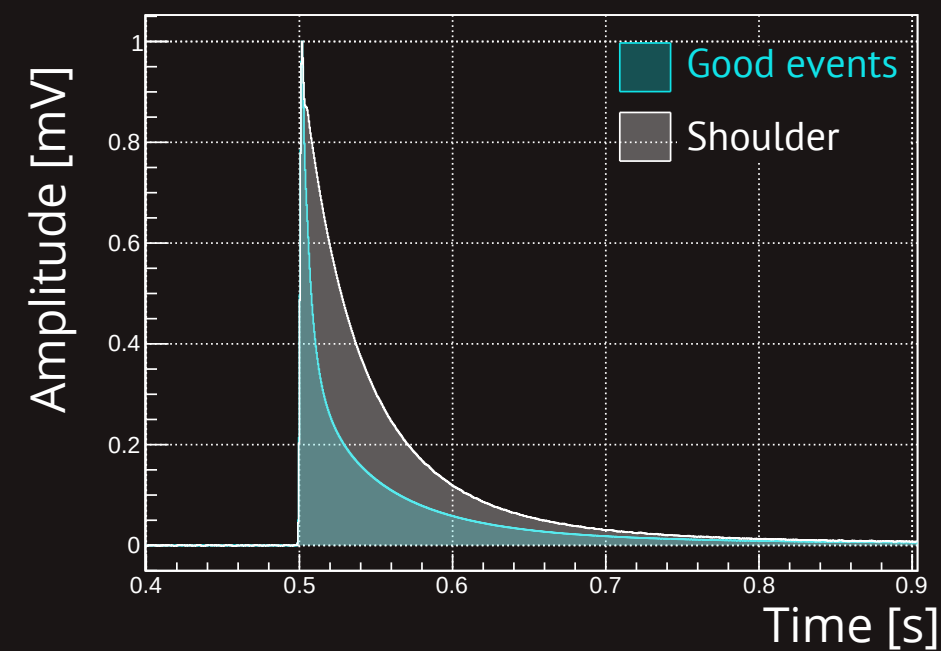
# LOW-ENERGY BACKGROUND

Ch 81, March

Unknown shoulder



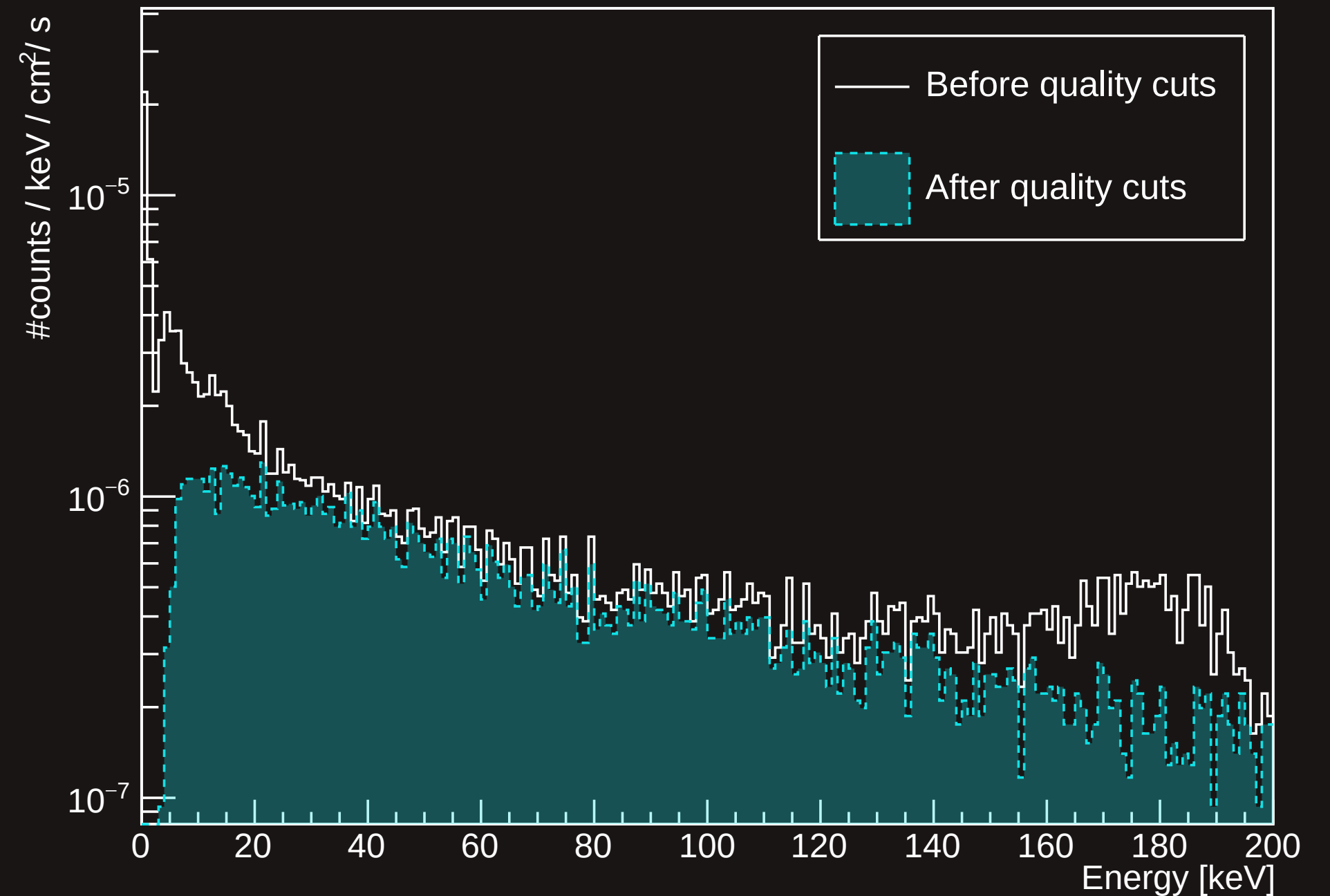
Average pulse comparison



Ch 81, March

Ch 81, March

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For  $E < 20$  keV

$$B = (1.10 \pm 0.11) \times 10^{-6} \text{ counts/keV/cm}^2/\text{s}$$

# CONCLUSIONS

- Successfully developed a **silicon bolometric detector** optimized for rare event detection.
- Demonstrated the effectiveness of the **LED self-calibration system**, covering a wide energy range from  $\sim$  keV to 10 MeV.
- First **alpha measurement** was conducted.
- The detector's sensitivity in both **high-energy alpha** and **low-energy regions** highlights its potential for next-generation neutrinoless double beta decay and dark matter experiments.

# NEXT STEPS

- Consider switching to **sapphire wafers** to improve energy resolution.
- Assemble the detector in a **cleanroom environment** to minimize contamination and improve background levels.
- Replace the LED calibration system with a **laser-based system** for better precision.



# JOIN US!

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SURFαCE recently funded by the Italian Ministry for University and Research via a FIS grant  
**We'll be hiring soon**, for info contact [giovanni.benato@gssi.it](mailto:giovanni.benato@gssi.it) or [anastasiia.shaikina@gssi.it](mailto:anastasiia.shaikina@gssi.it)

